

The present art specifically depends on producing a continuous and steady wattage output from each of the multiple secondary coils.

It is quite clear that in the Chass art, the position of the movable armature would upset the normal stability of the (added) secondary coils of the present art.

The arts of both Davis and Chass are far too narrow and focused to be in conflict with the present invention, which is quite specific in its purpose of providing multiple secondary coil sources of additional EMF output.

### **Conclusion**

For all of the above reasons, applicant submits that the specification and claims are now in proper form, and that the claims all define patentability over prior art. Therefore the applicant is now in condition for allowance, which action he respectfully solicit.

### **Conditional Request For Constructive Assistance**

Applicant has amended the specification and claims of this application so that they are proper, definite, and defines novel structure which is also unobvious. If, for any reason this application is not believed to be in full condition for allowance, the applicant respectfully request the constructive assistance and suggestions of the Examiner pursuant to MPEP SS 706.03(d) and SS 707.07(j) in order that the undersigned can place this application in allowable condition as soon as possible and without the need for further proceedings.

Very respectfully

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